

<b>Notice of References Cited</b>	Application/Control No. 10/747,983	Applicant(s)/Patent Under Reexamination WAYAMA ET AL.	
	Examiner John T. Kwon	Art Unit 3747	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0231644	11-2004	Ikeda et al.	123/399
	B	US-2004/0194757	10-2004	Irihune et al.	123/399
	C	US-6,819,102	11-2004	Hagio et al.	324/207.25
	D	US-6,756,780	06-2004	Hagio et al.	324/207.25
	E	US-6,701,892	03-2004	Wayama et al.	123/399
	F	US-6,407,543	06-2002	Hagio et al.	324/207.25
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	P					
	Q					
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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